

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial No.: 09/891,611

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation No.: 8874

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF MANUFACTURING DEVICES USING THE SYSTEM

Attorney Docket Number: 010817

Customer Number: 38834

## <u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

August 18, 2004

Sir:

Prior to continued examination, please amend the above-identified application as follows:

Amendment to the Claims begins on page 2 of this paper.

Remarks begin on page 23 of this paper.